

Notice of References Cited

Application No.

09/624,252

Applicant(s)

Schottker et al.

Examiner

Kunemund

Group Art Unit

1765

Page 1 of 1

U.S. PATENT DOCUMENTS

☆	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	5,637,146	8/10/1997	Chen.	117	200
B	6,252,255 B	6/26/2001	Ueta et al	257	94
C	2001/24871 A	9/27/2001	Yagi	938	604
D	5,602,418	2/11/97	Imai et al	257	627
E	6,072,189	8/6/00	Duggan	257	14
F					
G					
H					
I					
J					
K					
L					
M					

FOREIGN PATENT DOCUMENTS

☆	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
N	10/149992	8/2/98	Japan	Takeuchi et al		
O	4-187597	7/6/92	Japan	Ueno et al		
P						
Q						
R						
S						
T						

NON-PATENT DOCUMENTS

☆	DOCUMENT (Including Author, Title, Source, and Pertinent Pages)	DATE
U	Ambacher et al, "Thermal Stability and desorption of Group III nitrides,..." J. Vac. Sci. Tech. B 14(6) pp 3532-3542	Nov/Dec 1996
V		
W		
X		

* A copy of this reference is not being furnished with this Office action.
(See Manual of Patent Examining Procedure, Section 707.05(a).)